



SMW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4175**
Tomohiro OKUMURA et al. : Docket No. 2003_0919A
Serial No. 10/611,867 : Group Art Unit 1763
Filed July 3, 2003 : Examiner L. Alejandro Mulero

METHOD AND APPARATUS FOR
PLASMA DOPING

RESPONSE

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of March 21, 2005, Applicants hereby elect Group I, which is drawn to an apparatus and is embodied by claims 1-4.

Having made the required election, a full examination on the merits of the elected group is requested.

Respectfully submitted,

Tomohiro OKUMURA et al.

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